Client Reference No.: W0041-01EV



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Takenori Hirose, et al.

Application No.:

Filed: Herewith

For: Method and Apparatus for Managing Surface Image of Thin Film Device, and Method and Apparatus for Manufacturing Thin Film Device Using the Same

Examiner: Unassigned

Art Unit:

Unassigned

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR §1.97 and §1.98

**Assistant Commissioner for Patents** Washington, D.C. 20231

Sir:

The references cited on attached form PTO/SB/08A are being called to the attention of the Examiner. Copies of the references are enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement, since it is being submitted prior to the first Office Action. However, if a fee is required, the Commissioner is authorized to deduct such fee from Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

**PATENT** 

Takenori Hirose, et al. Application No.: Page +

Respectfully submitted,

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Robert C. Colwell Reg. No. 27,431

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(use as many sheets as necessary)				Examiner Name		3 <u>2</u> c	
Sheet	1	of	1	Attorney Docket Number	16869S-040900US	* <b>*</b>	

U.S. PATENT DOCUMENTS								
Examiner Initials *	Cite No.1	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Page Columns Lines		
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	FOREIGN PATENT DOCUMENTS								
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-	AU	JP	2000-009437		Hitachi, Ltd.	01-14-2000		Abstract	
	AV	JP	2000-294608		Tokyo Seimitsu Co.	10-20-2000		Abstract	
	AW	JP	3-138505		Fujitsu, Ltd.	06-12-1991		Abstract	
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<sup>&</sup>lt;sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.